

10/074354
02/11/02

N

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10C74354	FILING DATE 02/11/2002	CLASS 427	SUBCLASS 368	GAU 134 4762	EXAMINER P ADESSE
----------------------	---------------------------	--------------	-----------------	--------------------	-------------------------

**APPLICANTS: Scheer Craig; Stover John;

**CONTINUING DATA VERIFIED:
THIS APPLN CLAIMS BENEFIT OF 60/267,613 02/09/2001

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DC NOT PUBLISH <input checked="" type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO SCATP001
TITLE : Particle deposition system with enhanced speed and diameter accuracy U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for 0.6
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.
TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Application Examiner
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.				

FILED WITH:

DISK (CRF)

CD-ROM
(Attached in pocket on right inside flap)